

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
APPLICANT: MUKESH KHARE ET AL.

FOR: METHOD FOR IMPROVED PLASMA NITRIDATION OF ULTRA
THIN GATE DIELECTRICS

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§ 1.56, 1.97 AND 1.98

The Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

In compliance with the duty to disclose, applicants submit herewith a copy of each publication of which those designated by 37 CFR § 1.56 are aware; the publications are listed on attached form PTO-1449. The present Information Disclosure Statement shall not be construed as a representation that a search has been made or that no other art than that identified on the attached form PTO-1449 exists.

Consideration of this Information Disclosure Statement is respectfully requested, since the Examiner may consider the information provided herein material to the patentability of the subject application as defined in 37 CFR § 1.56.

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HDS
8-20-01



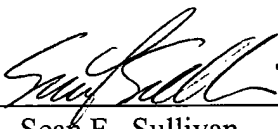
Since this Information Disclosure Statement is being filed within three months of the filing date of the subject application, no fee or certification under 37 CFR § 1.97 (e) is required.

However, in the event the Commissioner of Patents deems that any fee is required under 37 CFR §§ 1.16 and 1.17 in connection with this application, applicants' attorneys authorize that such fee be charged to Deposit Account No. 09-0458

Respectfully submitted,

MUKESH KHARE ET AL

CANTOR COLBURN LLP
Applicants' Attorneys

By: 
Sean F. Sullivan
Registration No. 38,328

Date: February 27, 2001
Address: 55 Griffin Road South, Bloomfield, CT 06002
Telephone: (860) 286-2929

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